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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : TAKAMATSU
PCT No : PCT/JP2004/009731
Filed : January 23, 2006
For : WAFER POLISHING METHOD
Dated : January 23, 2006

Hon. Commissioner of Patents
and Trademarks
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Prior to initial examination, please amend the above-identified application as follows: